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In re Patent Application of

HONG et al.

Atty. Ref.: 2826-9

Serial No. 10/047,119

Group: 2878

Filed: January 17, 2002

Examiner:

For: METHOD AND APPARATUS FOR CUTTING A MULTI-LAYER
SUBSTRATE BY DUAL LASER IRRADIATION

* * * * *

October 30, 2003

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

Attention is invited to the attached copy of a Notice of Refusal (with English language translation) issued by the Japan Patent Office on September 2, 2003 with respect to this disclosure and a copy of each document cited in it. A completed Form PTO-1449 is also attached.

Official citation and consideration of all the attached documents is requested. Please return to the undersigned a copy of the attached PTO-1449 with the examiner's initials in the left column [MPEP §609] with the next communication.

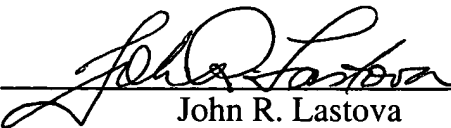
I hereby certify that each item of information contained herein was first cited in any communication from a foreign patent office in a counterpart foreign application not more than 3 months from the filing date of this statement [see 37 C.F.R. § 1.97(e) (1)].

The filing of an Information Disclosure Statement shall not be construed as a representation that a search has been made, an admission that the information cited is, or is considered to be, material to patentability [37 C.F.R. § 1.97(g) & (h)] or that no other material information exists.

HONG et al.
Serial No. 10/047,119

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION

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SERIAL NO.

2826-9

10/047,119

APPLICANT

HONG et al.

FILING DATE

GROUP

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2878

U.S. PATENT DOCUMENTS

*EXAMINED

(Use several sheets if necessary)

FILING DATE

DOCUMENT NUMBER

DATE _____

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FOREIGN PATENT DOCUMENTS

DOCUMENT

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COUNTRY

CLASS

SUBCLASS

TRANSLATION

YES NO

08-101970

1/16/96

Japan

ABSTRACT

2000-277550

10/6/2000

Japan

ABSTRACT

62-240186

10/20/87

Japan

ABSTRACT

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

Japan Notice of Refusal and English translation

***Examiner**

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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.